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JUN 17 2008

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No. : 10/623,866 Confirmation No. : 6399  
First Named Inventor : Yoshihiro KATO  
Filed : July 22, 2003  
TC/A.U. : 1763  
Examiner : J. Lund

Docket No. : 101246.52582US  
Customer No. : 23911

Title : Plasma Process System and Plasma Process Method

**AMENDMENT AND RESPONSE UNDER 37 C.F.R. § 1.116**

**Mail Stop AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In complete response to the final Office Action dated March 17, 2008, Applicant submits herewith the following Response.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this Response.

Remarks begin on page 10 of this Response.